

PTO-1449

Application No.

Applicant(s)

10/678,837

Tomblad et al.

Docket Number

Group Art Unit

Filing Date

068736.0231

2814 2822

October 3, 2003

Information Disclosure Citation in an Application

MAY 09 2005

U.S. PATENT DOCUMENTS

	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
A.	5132753	7/21/92	Chang et al.	257 367	655 284	3/23/90
B.	6613622	9/2/03	Nair et al.	438	188	7/15/02
C.						
D.						
E.						
F.						
G.						
H.						
I.						
J.						
K.						
L.						
M.						
N.						
O.						

FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
P.							
Q.							
R.							
S.							
T.							
U.							

NON-PATENT DOCUMENTS - DOCUMENT (Including Author, Title, Source, and Pertinent Pages)

W.	Dragon et al., "A Silicon MOS Process for Integrated RF Power Amplifiers," IEEE MTT-S Digest, Pages 257-260	6/17/96
X.		
Y.		
Z.		

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.